



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/881,408  
Filing Date ..... June 13, 2001  
Inventor ..... Kie Y. Ahn, et al  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2814  
Examiner ..... T. Le  
Attorney's Docket No. .... MI22-1534  
Title: A Dielectric Layer Forming Method and Devices Formed Therewith

**PRELIMINARY AMENDMENT TO ACCOMPANY RCE FILING AND  
RESPONSE TO DECEMBER 30, 2003 FINAL OFFICE ACTION**

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Assistant Commissioner for Patents  
Washington, D.C. 20231

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**AMENDMENTS**

**Introductory Comments**

The present Response is submitted in the Revised Amendment Format and therefore qualifies for waiver of provisions 37 CFR 1.121(a), (b), (c) and (d).

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